

UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Hajime YAMAMOTO et al.

Art Unit: 1795

Application Number: 10/647,247

**Examiner: Daborah Chacko Davis** 

Filed: August 26, 2003

Confirmation Number: 1773

MANUFACTURING SEMICONDUCTOR DEVICE, AND For: **METHOD OF** METHOD OF FORMING RESIST PATTERN

Attorney Docket Number: Customer Number: 031029

38834

## PETITION FOR EXTENSION OF TIME

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 August 29, 2008

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated April 1, 2008 for two months from July 1, 2008 to September 1, 2008.

Attached please find a check in the amount of \$460 for the cost of the extension of time. If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

Westerman, Hattori, Daniels & Adrian, LLP

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AGM/klf

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